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André Anders, Editor

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Dear Editor-in-Chief,

I am submitting the original manuscript to **Journal of Applied Physics** on Aug. 26th, 2016.

Authors: Nobuyoshi Hiramatsu, Fumiya Kusa, Akinobu Takegami, Kotaro Imasaka, Ikki Morichika and Satoshi Ashihara

Title: Propagation length of mid-infrared surface plasmon polaritons on gold: impact of morphology change by thermal annealing

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We believe that we prepared the manuscript adequately, to meet the criteria of JAP.

I look forward to hearing from you about our paper.

Yours sincerely,

Satoshi Ashihara